

Application/Control No.	Applicant(s)/Patent under Reexamination  ADACHI, NOKIHISA	
10/738,548		
Examiner	Art Unit	
Ren L. Yan	2854	

SEARCHED					
Class	Subclass	Date	Examiner		
sear	chated	3/28/06	R.Y.		
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
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